#### PATENT ASSIGNMENT

## Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: ASSIGNMENT

#### **CONVEYING PARTY DATA**

| Name            | Execution Date |
|-----------------|----------------|
| Shingo NAKAMURA | 03/17/2009     |

#### **RECEIVING PARTY DATA**

| Name:             | DAIKIN INDUSTRIES, LTD.          |  |
|-------------------|----------------------------------|--|
| Street Address:   | Umeda Center Buliding, 4-12,     |  |
| Internal Address: | Nakazaki-Nishi 2-Chome, Kita-ku, |  |
| City:             | Osaka-shi, Osaka                 |  |
| State/Country:    | JAPAN                            |  |

#### PROPERTY NUMBERS Total: 1

| Property Type       | Number   |
|---------------------|----------|
| Application Number: | 12377995 |

### CORRESPONDENCE DATA

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NAME OF SUBMITTER: Brett S. Sylvester

**Total Attachments: 1** 

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PATENT REEL: 022906 FRAME: 0692

Docket No. For Non-U.S. Clients

# Assignment

Whereas, I/We, <u>NAKAMURA Shingo</u>, of <u>c/o Yodogawa Seisakusho</u>, <u>DAIKIN INDUSTRIES</u>, <u>LTD</u>., 1-1, <u>Nishihitotsuya</u>, <u>Settsu-shi</u>, <u>Osaka 5660044</u>, <u>Japan</u> hereinafter called assignor(s), have invented certain improvements in

| assignor(s), have invented certain im  | provements in  |
|--|--|
| SOLUTION FOR REMOVING RES  | SIDUE AFTER SEMICONDUCTOR DRY PROCESS AND  |
| METHOD OF REMOVING THE R   | ESIDUE USING THE SAME  |
| and executed an application for Lette<br>March 17, 2009 ; and  | ers Patent of the United States of America therefor on   |
| Whereas,   | DAIKIN INDUSTRIES, LTD., of  |
|  | Umeda Center Building, 4-12, Nakazaki-   |
|  | Nishi 2-Chome, Kita-ku, Osaka-shi,   |
|  | Osaka 5308323, Japan   |
| (assignee), desires to acquire invention, and to any United States p   | the entire right, title, and interest in the application and patents to be obtained therefor;  |
| Now therefore, for valuable of   | consideration, receipt whereof is hereby acknowledged,   |
| invention disclosed therein for the U under 35 U.S.C. §119, and I/we requissue any Letters Patent granted upon successors and assigns; and I/we will necessary by the assignee in connect do so by the assignee. | the entire right, title and interest in the application and the nited States of America, including the right to claim priority test the Director of the U.S. Patent and Trademark Office to a the invention set forth in the application to the assignee, its I execute without further consideration all papers deemed ion with the United States application when called upon to equest our attorneys SUGHRUE MION, PLLC of 2100 |
| Pennsylvania Avenue, NW, Washing   | gton, DC 20037-3213 to insert here in parentheses  |
| number and filing date of said applic  | and Confirmation number  February 18, 2009 the application eation when known.  |
| Date: March 17, 2009 Shing<br>s/ NAKAMUR   | in hakamurer   |
| s/ NAKAMUR   | A Shingo   |
| Date:  |  |
| s/   |  |
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(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. §261)

PATENT REEL: 022906 FRAME: 0693

**RECORDED: 07/02/2009**